

**METHOD OF FABRICATING SUB-MICRON
HEMISPHERICAL AND HEMICYLINDRICAL STRUCTURES
FROM NON-SPHERICALLY SHAPED TEMPLATES**

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Abstract of the Disclosure

10 A method for manufacturing hemi-cylindrical and hemi-spherical micro structures is provided. A pattern is formed onto a substrate, and a layer of material is subsequently grown onto the substrate. Due to growth characteristics, the layer will form radially symmetric features when grown to an appropriate thickness.

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